What is claimed is:

| 1 | 1. A conversion device for use in an imaging system |
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| 2 | comprising: |
| 3 | a first perforated plate portion forming a plurality of collimator |
| 4 | channels separated by a plurality of thin collimator walls; |
| 5 | a second perforated plate portion forming a plurality of |
| 6 | scintillator channels separated by a plurality of thin scintillator walls; |
| 7 | reflective coating applied to the inside scintillator surface of said |
| 8 | plurality of thin scintillator walls; and |
| 9 | a scintillator material filling said plurality of scintillator |
| 10 | channels. |
| | |
| 1 | 2. A conversion device for use in an imaging system as in |
| 2 | claim 1 wherein said first perforated plate portion and said second perforated |
| 3 | plate portion are formed from a single perforated plate element. |
| | |
| 1 | 3. A conversion device for use in an imaging system as in |
| 2 | claim 1 wherein said collimator channels comprise a spacing pitch of less than |
| 3 | or equal to 2mm. |
| | |
| 1 | 4. A conversion device for use in an imaging system as in |
| 2 | claim 1 wherein said collimator channels comprise a collimator channel width |
| 3 | less than 500 microns. |
| 1 | 5. A conversion device for use in an imaging system as in |
| | |
| 2 | claim 1 wherein said then collimator walls comprise a wall thickness of 100 |
| 3 | microns. |
| 1 | 6. A conversion device for use in an imaging system as in |
| 2 | claim 1 wherein said scintillator material comprises luminescent glass. |

| | 1 | 7. A conversion device for use in an imaging system as in |
|-----|---|---|
| | 2 | claim 6 wherein said luminescent glass comprises luminescent materials |
| | 3 | dispersed in a glassy matrix. |
| • • | 1 | 8. A conversion device for use in an imaging system as in |
| | 2 | claim 6 wherein said luminescent glass comprises a glass ceramic containing |
| | 3 | crystalline particles. |
| | 1 | 9. A conversion device for use in an imaging system as in |
| | 2 | claim 1 wherein said scintillator material comprises luminescent polymer. |
| | 1 | 10. A conversion device for use in an imaging system as in |
| | 2 | claim 9 wherein said luminescent polymer comprises inorganic phosphor |
| | 3 | particles suspended in a polymer matrix. |
| | 1 | |
| | 1 | 11. A conversion device for use in an imaging system as in |
| | 2 | claim 1 wherein said plurality of thin collimator walls is comprised of a high |
| | 3 | atomic number metal. |
| | 1 | 12. A conversion device for use in an imaging system as in |
| | 2 | claim 1 wherein said first perforated plate portion comprises a perforated copper |
| | 3 | plate. |
| | 1 | 13. A conversion device for use in an imaging system as in |
| | 2 | claim 1 wherein said reflective coating comprises TiO2. |
| | 1 | 14. A conversion device for use in an imaging system as in |
| | 2 | claim 1 wherein said scintillator material comprises a luminescent material that |
| | 3 | does not decompose when dispersed in molten glass, said luminescent material |
| | 4 | suspended in said molten glass. |
| | 1 | 15. A conversion device for use in an imaging system |
| | 2 | comprising: |

|) | a periorated plate forming a pluranty of scintillator channels |
|----|--|
| 4 | separated by a plurality of thin scintillator walls; |
| 5 | reflective coating applied to the inside scintillator surface of said |
| 6 | plurality of thin scintillator walls; and |
| 7 | a scintillator material filling said plurality of scintillator |
| 8 | channels. |
| 1 | 16. A method of manufacturing a conversion device for use |
| 2 | in an imaging system comprising: |
| 3 | perforating a plate element to form a plurality of scintillator |
| 4 | channels separated by a plurality of thin scintillator walls; |
| 5 | coating an inside surface of said plurality of thin scintillator |
| 6 | walls with a reflective coating; and |
| 7 | filling said plurality of scintillator channels with a scintillator |
| 8 | material. |
| 1 | 17. A method of manufacturing a conversion device for use |
| 2 | in an imaging system as described in claim 16, wherein said filling said plurality |
| 3 | of scintillator channels comprises: |
| 4 | placing a scintillator material on said performated plate element; |
| 5 | applying a load to said scintillator material such that said |
| 6 | scintillator material is pressed onto said perforated plate element; |
| 7 | heating said scintillator material to a slumping temperature such |
| 8 | that said scintillator material fills said plurality of scintillator channels. |
| 1 | 18. A method of manufacturing a conversion device for use |
| 2 | in an imaging system as described in claim 16, further comprising: |
| 3 | grinding said scintillator material such that a scintillator upper |
| 4 | surface is planar with a perforated plate upper surface. |
| 1 | 19. A method of manufacturing a conversion device for use |
| 2. | in an imaging system as described in claim 18, further comprising: |

| 3 | grinding said perforated plate upper surface such that a |
|---|--|
| 1 | perforated plate depth is adjusted. |
| | |
| L | 20. A method of manufacturing a conversion device for use |
| 2 | in an imaging system as described in claim 16, wherein said filling said plurality |
| 3 | of scintillator channels comprises: |
| 1 | forming a block of scintillator material with said performated |
| 5 | plate element embedded within said block of scintillator material; and |
| 5 | grinding said scintillator material such that a scintillator upper |
| 7 | surface is planar with a perforated plate upper surface. |
| | |
| 1 | 21. A method of manufacturing a conversion device for use |
| 2 | in an imaging system as described in claim 16, wherein said scintillator material |
| 3 | only partially fills said perforated plate element such that a scintillator function |
| 4 | is generated by said scintillator material and a collimator function is generated |
| 5 | by an unfilled portion. |